

Notice of References Cited	Application/Control No. 10/533,677	Applicant(s)/Patent Under Reexamination DE LUCA ET AL.	
	Examiner JEONG S. PARK	Art Unit 2154	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0143961	10-2002	Siegel et al.	709/229
*	B	US-6,434,700	08-2002	Alonso et al.	713/169
*	C	US-2001/0016880	08-2001	Cai et al.	709/321
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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